

INSTITUTE OF PHYSICS

PHYSICS AND APPLICATIONS OF SEMICONDUCTOR QUANTUM STRUCTURES

EDITED BY
T YAO
J-C WOO

© IOP Publishing Ltd 2001

All rights reserved. No part of this publication may be reproduced, stored in a retrieval system or transmitted in any form or by any means, electronic, mechanical, photocopying, recording or otherwise, without the prior permission of the publisher. Multiple copying is permitted in accordance with the terms of licences issued by the Copyright Licensing Agency under the terms of its agreement with the Committee of Vice-Chancellors and Principals.

British Library Cataloguing-in-Publication Data

A catalogue record for this book is available from the British Library.

ISBN 0 7503 0637 8

Library of Congress Cataloging-in-Publication Data are available

Commissioning Editor: Tom Spicer
Production Editor: Simon Laurenson
Production Control: Sarah Plenty
Cover Design: Victoria Le Billon
Marketing Executive: Colin Fenton

Published by Institute of Physics Publishing, wholly owned by The Institute of Physics, London

Institute of Physics Publishing, Dirac House, Temple Back, Bristol BS1 6BE, UK
US Office: Institute of Physics Publishing, The Public Ledger Building, Suite 1035, 150 South Independence Mall West, Philadelphia, PA 19106, USA

Typeset in T_EX using the IOP Bookmaker Macros
Printed in the UK by MPG Books Ltd, Bodmin

Preface

Since the revolutionary idea of 'artificial' semiconductor superlattice structures proposed by Esaki and Tsu in 1969, semiconductor quantum structures have opened up a new era not only in the research of physics and materials science, but also in the development of electronic and optical devices. In the initial stage of this field, study was limited to the two-dimensionally confined electron system, which led to the discovery of many novel phenomena such as quantum Hall effects, quantum confined Stark effects, Aharonov–Bohm effects. It is obvious that these discoveries are due to advances in materials science, in particular the atomic-scale growth techniques such as molecular beam epitaxy and metal organic chemical vapour deposition. Well-known examples of application are quantum well lasers, high electron mobility transistors and resonant tunnelling diodes, which are based on the two-dimensional confinement of electrons.

In recent years, efforts in this field have been devoted to the fabrication and characterization of quantum structures with reduced dimensionality, namely one- and zero-dimensional structures, with remarkable advancement in material processing and micro-fabrication technology. The successful fabrication of quantum wire and quantum dot structures have enabled scientists to explore novel properties and new-concept devices. Some of the outstanding examples are Coulomb blockade effects, microcavity lasers, exciton-based nonlinear optical effects, and single-electron transistors.

In view of the rapid progress in this multidisciplinary area related to semiconductor quantum structures, the researchers in this field felt a need to hold a forum, where scientists in various backgrounds could get together to review recent achievements and to discuss the future directions of development. In order to fulfil such a demand, the 1998 Asian Science Seminar entitled the International Workshop on Physics and Application of Semiconductor Quantum Structures has been formed under the sponsorship of the Japan Society for the Promotion of Science (JSPS) and the Korea Science and Engineering Foundation (KOSEF).

In this workshop, experts and leading scientists were invited to cover the overall spectrum on the research activities in this field. This book is comprised of the invited lectures of this workshop and a number of reviews. This book starts with a perspective review on the evolution of semiconductor superlattices and quantum nanostructures (part 1) followed by the fabrication and characterization

of quantum structures (part 2), transport properties (part 3), optical properties (part 4), spin dependent properties (part 5), and device applications (part 6).

We would like to extend our sincere gratitude to the contributing authors of the articles, the organizing members of the workshop, and especially the sponsoring organizations of the workshop for their kind cooperation and support.

Takafumi Yao and Jong-Chun Woo

February 2000

Contents

Preface	xv
 PART 1	
Plenary lecture	1
1 The evolution of semiconductor superlattices and quantum nanostructures	
<i>L Esaki</i>	3
1.1 Introduction	3
1.2 Quantum structures	5
References	9
 PART 2	
Fabrication and characterization of quantum structures	11
2 Formation and characterization of semiconductor nanostructures	
<i>J Motohisa and T Fukui</i>	13
2.1 Introduction	14
2.2 InGaAs quantum wires on GaAs multiatomic steps	15
2.2.1 Quantum nanostructures utilizing atomic steps	15
2.2.2 Formation of GaAs multiatomic steps on GaAs (001) vicinal surfaces	17
2.2.3 Fabrication of InGaAs quantum wire structures using multiatomic steps	20
2.2.4 Optical characterization of InGaAs quantum wires	24
2.2.5 InGaAs quantum wire lasers	28
2.3 GaAs and InAs quantum dots and related nanostructures by selective area growth	33
2.3.1 MOVPE selective area growth for quantum nanostructures	33
2.3.2 Selective area MOVPE of GaAs and InAs quantum dots on pyramidal structures	34

2.3.3	Fabrication and characterization of high-density quantum dot arrays and quantum dot network	39
2.3.4	Position controlled InAs quantum dots on GaAs pyramidal structures	44
2.3.5	Fabrication of single electron transistors and their transport properties	51
2.3.6	Resistance-load SET inverter circuit	55
2.4	Summary and outlook	58
	Acknowledgments	60
	References	61
3	New quantum wire and quantum dot structures by selective MBE on patterned high-index substrates	
	<i>K H Ploog and R Nötzel</i>	65
3.1	Introduction	65
3.2	Results	66
3.2.1	Quantum wires on stripe-patterned GaAs(311)A	66
3.2.2	Dot-like structures on square- and triangular-patterned GaAs(311)A	67
3.2.3	Coupled wire-dot arrays on stripe-patterned GaAs(311)A	68
3.2.4	Uniform quantum dot arrays by hydrogen-enhanced step bunching on stripe-patterned GaAs(311)A	71
3.3	Concluding remarks	72
	Acknowledgments	73
	References	74
4	New fabrication techniques and optical properties of GaN and Si quantum dots	
	<i>Y Aoyagi, S Tanaka and X Zhao</i>	75
4.1	Introduction	75
4.2	Formation of self-assembled GaN quantum dots using Si antisurfactant and optical properties of the dots	76
4.2.1	Experimental procedure	76
4.2.2	Experimental results	77
4.2.3	Discussion	80
4.3	Formation of nanocrystalline Si by Er doping and optical properties of the nanocrystal	81
4.3.1	Experimental procedure	82
4.3.2	Experimental results	82
4.4	Conclusion	86
	References	86
5	Dislocation filtering techniques for MBE large mismatched heteroepitaxy	
	<i>J M Zhou, Q Huang, H Chen and C S Peng</i>	88

5.1	Introduction	88
5.2	Survey of several dislocation filtering methods	89
5.2.1	Constant-composition layer	89
5.2.2	Strained-layer superlattices (SLS)	90
5.2.3	Composition graded layer	91
5.2.4	Patterned substrate	92
5.3	Low-temperature Si and/or GeSi buffer for GeSi alloy strain relaxation	92
5.4	New initial growth method for pure cubic GaN on GaAs (001)	97
5.5	InAs growth on GaAs using new prelayer technology	100
5.6	Conclusion	103
	References	104

6 Growth of widegap II–VI quantum structures and their optical properties

T Yao **106**

6.1	Introduction	106
6.2	ZnS/(ZnSe) _n /ZnS quantum dots	108
6.2.1	Fabrication of ZnS/(ZnSe) _n /ZnS ultrathin quantum structures and their characterization	108
6.2.2	Temperature dependence of PL of ZnS/ZnSe quantum dot structures	114
6.2.3	Time resolved PL	118
6.2.4	The effect of substrate temperature on the formation of quantum structures	120
6.2.5	Mn doped ZnSe quantum dots	123
6.3	CdSe/ZnSe quantum dots	127
6.3.1	Alloying at the heterointerface	127
6.3.2	Self-organized formation of CdSe quantum dots	130
6.3.3	Spectral diffusion in CdSe QDs	132
6.4	Summary	135
	Acknowledgments	135
	References	136

PART 3

Transport properties in quantum structures 139

7 Theory of quantum transport in mesoscopic systems: antidot lattices

T Ando, S Uryu, T Nakanishi and S Ishizaka **141**

7.1	Introduction	141
7.2	Antidot lattices	142
7.3	Commensurability peaks	144
7.4	Aharonov–Bohm-type oscillation	149
7.5	Triangular antidot lattices	153

7.6	Altshuler–Aronov–Spivak oscillation	156
7.7	Scattering matrix formalism	158
7.7.1	Quantum-wire junction	158
7.7.2	Energy bands and density of states	160
7.7.3	Commensurability peaks and Aharonov–Bohm oscillation	163
7.8	Anderson localization	166
7.8.1	Experiments	166
7.8.2	Thouless-number method	168
7.8.3	Numerical results	171
7.8.4	Localization oscillation	172
7.9	Summary and conclusion	174
	Acknowledgments	175
	References	175
8	Edge states in magnetic quantum structures and composite fermion systems	
	<i>G Ihm, H-S Sim, K J Chang and S J Lee</i>	178
8.1	Introduction	178
8.2	Magnetic quantum dot	180
8.3	Composite fermions in an antidot: application of magnetic quantum dot	184
8.4	Composite fermion edge channels	188
8.5	Conclusion	191
	Acknowledgments	192
	References	192
9	Electronic states in circular and ellipsoidally deformed quantum dots	
	<i>S Tarucha, D G Austing, S Sasaki, L P Kouwenhoven, S M Reimann, M Koskinen and M Manninen</i>	194
9.1	Introduction	195
9.2	Experimental details	196
9.3	Electronic properties of circular quantum dots	198
9.3.1	Atom-like properties: shell structure and Hund's first rule	198
9.3.2	Magnetic field dependence	199
9.3.3	Spin triplet for the four-electron ground state	201
9.4	Electronic properties of elliptical quantum dots	203
9.4.1	Deformed dots in rectangular mesa devices	203
9.4.2	Magnetic field dependence	206
9.4.3	Study of Zeeman effect on the spin states	207
9.5	Comparison to model calculations	209
9.6	Conclusions	213
	Acknowledgments	213
	References	214

PART 4	
Optical properties	217
10 Electron-hole and exciton systems in low dimensions	219
<i>T Ogawa</i>	219
10.1 Introduction	219
10.2 Remarks on low-dimensional excitons	220
10.3 Single-exciton problem	221
10.3.1 One-photon absorption process	223
10.3.2 Two-photon absorption process	226
10.3.3 Dielectric confinement effect	228
10.4 A few exciton problems	230
10.4.1 An excitonic molecule in one dimension	230
10.4.2 Optical nonlinearity due to excitons	233
10.5 Excitonic many-body problems	237
10.5.1 Exciton Bose-Einstein condensation and density waves in one dimension	237
10.5.2 Optical responses of the Tomonaga-Luttinger liquid: the Mahan exciton	241
10.6 Conclusions and prospect	247
Acknowledgments	250
References	250
11 Size quantization and electron dynamics in nanometre-size semiconductors	
<i>T Goto</i>	253
11.1 Introduction	253
11.2 Two-dimensional size confinement in ultrathin PbI ₂ nanocrystals	254
11.3 Size confinement of an exciton internal motion in ultrathin PbI ₂ nanocrystals	258
11.4 Nonlinear optical processes in CuCl nanocrystals	259
11.5 Photoinduced phenomena in luminescence spectra of a single CdSe nanocrystal	267
References	271
12 Electronic properties of InAs/GaAs quantum dots	
<i>R Heitz, I Mukhametzhanov, O Stier, A Hoffmann, A Madhukar and D Bimberg</i>	273
12.1 Introduction	273
12.2 Experimental	275
12.3 Experimental results and discussion	277
12.3.1 Energy transfer processes	278
12.3.2 Temperature dependence	282
12.3.3 Local-equilibrium emission	286
12.3.4 Excited-state transitions	291

12.3.5	Phonon-assisted exciton recombination	293
12.4	Conclusions	296
	Acknowledgments	297
	References	297
13	Graded and coupled quantum wells for emission of radiation by intersubband emission	
	<i>K D Maranowski, A C Gossard and K L Chapman</i>	300
13.1	Introduction	300
13.2	Review of intersubband emission	302
13.3	Emission from parabolic quantum wells	307
13.4	Optical excitation of parabolic quantum wells	313
13.5	Quantum interference effects	315
13.5.1	Absorption in coupled quantum wells	317
13.5.2	Interference of intersubband transitions	321
13.6	Conclusions	331
	Acknowledgments	333
	References	333
PART 5		
	Spin-dependent properties	335
14	Spin-dependent properties of magnetic III-V semiconductors	
	<i>H Ohno</i>	337
14.1	Introduction	337
14.2	Preparation and basic properties of (Ga,Mn)As	338
14.2.1	Molecular beam epitaxy	339
14.2.2	Lattice constant and local lattice configuration	339
14.3	Magnetic and magnetotransport properties	340
14.3.1	Magnetic properties	340
14.3.2	Magnetotransport properties	341
14.4	Origin of ferromagnetism	345
14.5	Heterostructures	347
14.5.1	Ferromagnetic/non-magnetic/ferromagnetic trilayers	347
14.5.2	Resonant tunnelling structures	351
14.6	Conclusion	352
	Acknowledgments	352
	References	352
15	Zeeman separation in GaAs quantum structures	
	<i>J-C Woo and K-H Yoo</i>	355
15.1	Introduction	355
15.2	Zeeman effects of GaAs and $\text{Al}_x\text{Ga}_{1-x}\text{As}$ bulk	356
15.3	GaAs/ $\text{Al}_x\text{Ga}_{1-x}\text{As}$ quantum well	357
15.4	GaAs/ $\text{Al}_x\text{Ga}_{1-x}\text{As}$ quantum dot and quantum wire	362

15.5 Concluding remarks	366
References	366

PART 6

Device applications	369
---------------------	-----

16 Self-assembling of silicon quantum dots and its application to novel nanodevices

<i>M Hirose</i>	371
16.1 Introduction	371
16.2 Self-assembling of silicon quantum dots	372
16.3 Quantum confinement in silicon dot	375
16.3.1 Valence band spectra and charging effect	375
16.3.2 Comparison with theory	379
16.4 Resonant tunnelling through a Si quantum dot	380
16.4.1 Device fabrication	380
16.4.2 Resonant tunnelling characteristics	381
16.5 Silicon quantum dot memory	382
16.5.1 Device fabrication	383
16.5.2 Memory characteristics of Si quantum dot floating gate MOS structures	383
16.6 Summary	385
Acknowledgment	385
References	385

17 Quantum devices based on III-V compound semiconductors

<i>H Hasegawa, H Fujikura and H Okada</i>	387
17.1 Introduction	388
17.2 Brief general overview on compound semiconductor quantum devices	389
17.2.1 Wave-particle duality and devices	389
17.2.2 Quantum wave devices	389
17.2.3 Single electron devices	391
17.3 Formation of GaAs- and InP-based quantum structure by molecular beam epitaxy	395
17.3.1 Approaches for formation of quantum structures	395
17.3.2 Selective MBE growth of InGaAs quantum wires, dots and wire-dot coupled structures	396
17.4 Control of surfaces and interfaces of nanostructures	405
17.4.1 A key issue for nanofabrication	405
17.4.2 Formation technology of damage-free Schottky gates for quantum structures	406
17.5 Compound semiconductor quantum wave devices	413

17.5.1	Various lateral quantum wave devices investigated at RCIQE	413
17.5.2	Schottky IPG single and coupled quantum wire transistors	413
17.6	Compound semiconductor single electron devices	418
17.6.1	Key issues for SEDs and efforts at RCIQE	418
17.6.2	Voltage gain in GaAs-based lateral SETs having novel Schottky gates	420
17.6.3	Single electron memory devices utilizing IPG quantum wire transistor and metal nanodots	425
17.7	Conclusion	429
	Acknowledgments	429
	References	429
18	Quantum interference in corrugated conducting wire transistors	
<i>K Park</i>		433
18.1	Issues and challenges in semiconductor nanostructures	433
18.2	Quantum transport; electron interference	436
18.3	Review on lateral quantum interference devices	438
18.4	Various characteristics of quantum interference devices	440
18.4.1	Uneven gate conducting wire	440
18.4.2	Electrostatic Aharonov-Bohm ring transistor	442
18.4.3	Electron diffraction transistor	446
18.4.4	One-dimensional corrugated quantum channel	448
18.5	Summary	449
	Acknowledgments	450
	References	450
19	Non-Markovian optical gain of strained-layer quantum-well lasers with many-body effects	
<i>D Ahn</i>		452
19.1	Introduction	452
19.2	The model	453
19.3	Numerical results and discussion	459
19.4	Conclusions	463
	Acknowledgment	463
	References	463
20	Generation of non-classical lights from semiconductor light emitters	
<i>M Yamanishi, H Sumitomo, M Kobayashi and Y Kadoya</i>		465
20.1	Introduction	465
20.2	Squeezing in photon-number fluctuations under constant-current operation	466
20.2.1	Basic physics for constant-current operation	466
20.2.2	Experimental arrangement and results (constant-current operation)	468

20.2.3	Pump-current-dependence of squeezing bandwidth	471
20.2.4	Framework of backward-pump model	471
20.2.5	Theoretical bandwidth for noise suppression in comparison with experimental results	474
20.3	Squeezing in photon-number fluctuations due to the backward pump process	476
20.3.1	Basic physics for constant-voltage operation	476
20.3.2	Experimental arrangements and results (constant-voltage operation)	477
20.3.3	New squeezing mechanism based on the backward pump process	480
20.4	Conclusions	482
	References	483

PART 1

PLENARY LECTURE

Chapter 1

The evolution of semiconductor superlattices and quantum nanostructures

Leo Esaki

Tsukuba, Ibaraki 305-0047, Japan

In the early twentieth century, encounters with physical phenomena which require detailed analyses in nanoscale, such as electron motion, prompted the advent of quantum mechanics, since Newtonian mechanics could not possibly provide an adequate explanation for them. Electron tunnelling through nanoscale barriers is the most direct consequence of the law of quantum mechanics, for which the Esaki tunnel diode gave most convincing experimental evidence in 1957. Following the evolutionary path of quantum nanostructures, significant milestones are presented, including the birth of semiconductor superlattices, resonant tunnel diodes, quantum wires and dots.

1.1 Introduction

The twentieth century will be characterized by the fact that science and technology have made remarkable progress, including the establishment of quantum mechanics, the development of semiconductor devices with the invention of the transistor and the evolution of computers/telecommunications.

In the early century, encounters with physical phenomena such as the electron's motion or the photon's behaviour for which Newtonian mechanics could not possibly provide an adequate explanation, prompted the advent of quantum mechanics. The framework of quantum mechanics was established in the superb work of Werner Heisenberg, Erwin Schrödinger, Paul Dirac and Max Born in the period 1925–6.

During the infancy of the quantum theory, de Broglie [1] introduced a new fundamental hypothesis that matter was endowed with a dualistic nature—particles may also have the characteristics of waves. This hypothesis found

expression, in the hands of Schrödinger [2], in the definite form now known as the Schrödinger wave equation, whereby an electron is assumed to be represented by a solution to this equation. The continuous non-zero nature of such solutions, even in classically forbidden regions of negative kinetic energy, implies an ability to penetrate such forbidden regions and a probability of tunnelling from one classically allowed region to another. The concept of tunnelling itself arises from this quantum-mechanical result, and has no analogy in classical mechanics. The subsequent experimental manifestations of that concept can be regarded as one of the early triumphs of the quantum theory. For instance, in 1928, Fowler and Nordheim [3] explained, on the basis of electron tunnelling, the main features of the phenomenon of electron emission from cold metals by high external electric fields, which had been unexplained since its observation by Lilienfeld in 1922.

In 1932, Wilson [4], Frenkel and Joffe [5], and Nordheim [6] applied quantum mechanical tunnelling to the interpretation of metal–semiconductor contact rectifiers such as those made from selenium or cuprous oxide. Apparently, this theory was accepted for a number of years until it was finally discarded after it was realized that it predicted rectification in the wrong direction for ordinary, practical diodes. It is now clear that, in the usual circumstances, the surface barriers met by semiconductors in contact with metals are far too thick to observe any tunnelling current.

In 1934, the development of the energy-band theory of solids prompted Zener [7] to propose interband tunnelling as an explanation for dielectric breakdown. He calculated the rate of transitions from a filled band to a next-higher unfilled band by the application of an electric field. In effect, he showed that an energy gap could be treated in the manner of a potential barrier. The Zener mechanism in dielectric breakdown, however, has never been proved to be important in reality. If a high electric field is applied to the bulk crystal of a dielectric or semiconductor, avalanche breakdown (electron–hole pair generation) generally precedes tunnelling, and thus the field never reaches a critical value for tunnelling.

With the invention of the transistor in 1947 came a renewed interest in the tunnelling process. Around 1950, the technology of Ge p–n junction diodes was developed, and efforts were made to understand the junction properties. In explaining the reverse-bias characteristic, McAfee *et al* [8] applied a modified Zener theory and asserted that low-voltage breakdown in Ge diodes resulted from interband tunnelling. Results of later studies, however, indicated that most Ge junctions broke down by avalanche, but by that time the name ‘Zener diodes’ had already been given to the low-breakdown Si diodes. Actually, Zener diodes are almost always avalanche diodes.

In these circumstances, in 1956, the investigation of interband tunnelling was initiated with heavily-doped Ge p–n junctions, where the junction width was successfully reduced to the range of nanometres.

We first obtained a backward diode which was more conductive in the reverse direction than in the forward direction. In this respect it agreed with